

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Jun Koyama et al. Art Unit : Unknown  
Serial No. : New DIV Appln. Examiner : Unknown  
Filed : July 17, 2003  
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Under 35 USC §120, this application relies on the earlier filing dates of application serial number 09/652,652, filed on August 31, 2000 and application serial number 08/996,357, filed December 22, 1997. The attached list of references were submitted to and/or cited by the Office in the prior applications and, therefore, are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: July 17, 2003

  
John F. Hayden  
Reg. No. 37,640

Fish & Richardson P.C.  
1425 K Street, N.W.  
11th Floor  
Washington, DC 20005-3500  
Telephone: (202) 783-5070  
Facsimile: (202) 783-2331

Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 07977-209003	Application No. New DIV Appln.
<b>Information Disclosure Statement by Applicant</b> <small>(Use several sheets if necessary)</small> <small>(37 CFR §1.98(b))</small>		Applicant Jun Koyama et al.			
		Filing Date July 17, 2003	Group Art Unit Unknown		

<b>U.S. Patent Documents</b>							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2001-0022677	09/2001	Hirakata et al			
	AB	4,914,503	04/1990	Shirato et al.			
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	AP	6,384,818	05/2002	Yamazaki et al.			

<b>Foreign Patent Documents or Published Foreign Patent Applications</b>							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes      No
	AQ						

<b>Other Documents (include Author, Title, Date, and Place of Publication)</b>							
Examiner Initial	Desig. ID	Document					
	AR						
	AS						

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	